

Electronic Patent Application Fee Transmittal

Application Number:	10071809			
Filing Date:	07-Feb-2002			
Title of Invention:	Method for selectively etching silicon and/or metal silicides			
First Named Inventor/Applicant Name:	Tinghao F. Wang			
Filer:	Daniel W Celander/Wendy Lostumbo			
Attorney Docket Number:	10200-16			
Filed as Large Entity				
Utility Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Request for continued examination	1801	1	790	790
Total in USD (\$)				790